



Fig. 1

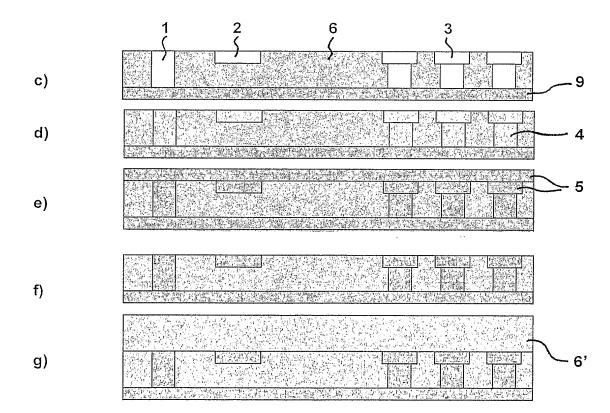


Fig. 2

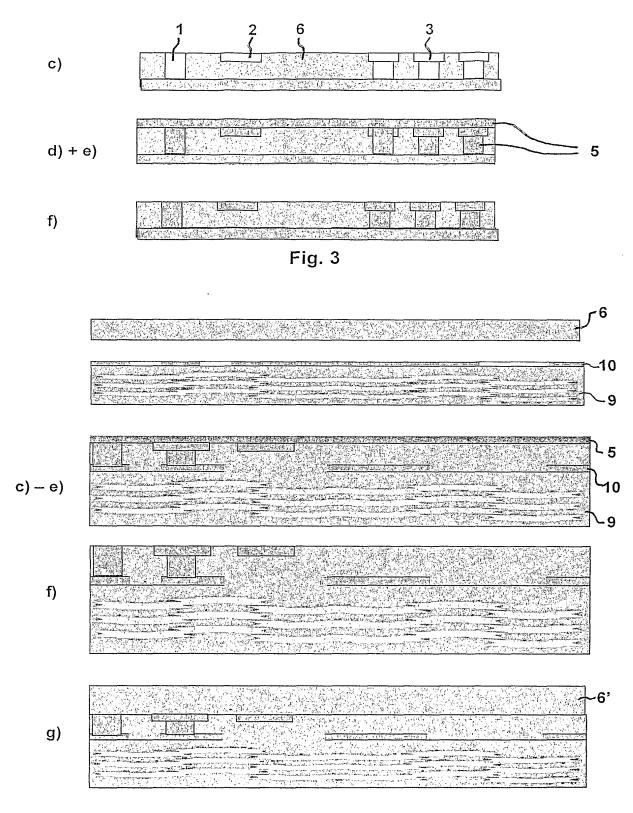
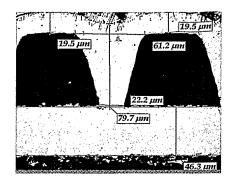


Fig. 4



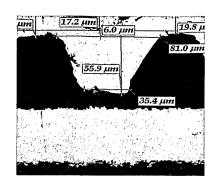
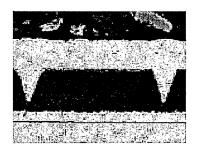


Fig. 5



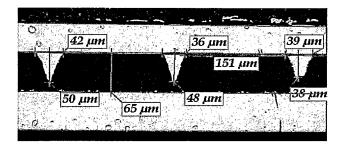


Fig. 6

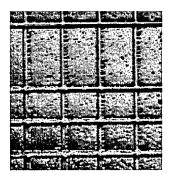


Fig. 7

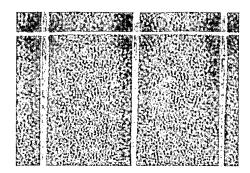
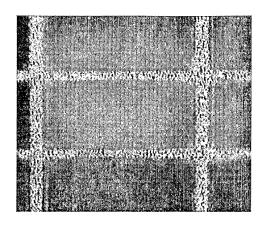


Fig. 8



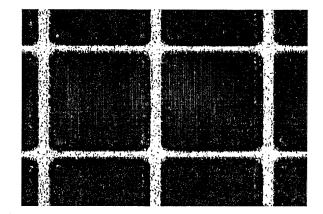


Fig. 9

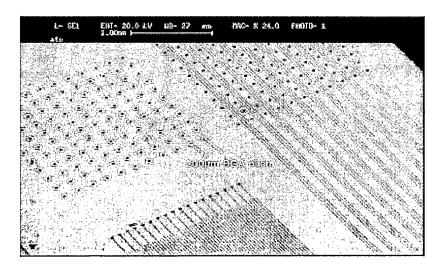


Fig. 10

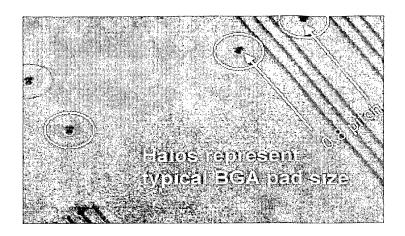


Fig. 11

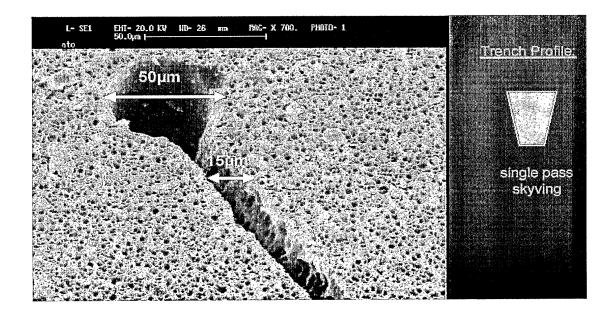
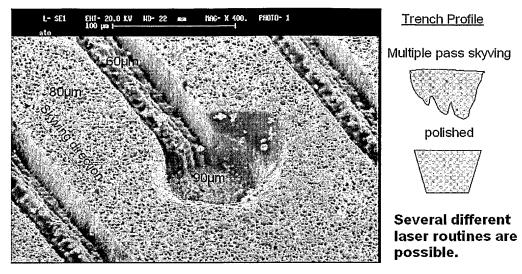


Fig. 12

Via² - Process Multi pass skiving — before laser polish - 0.8 mm BGA



SEM - Detail of hole trench intersection

Fig. 13

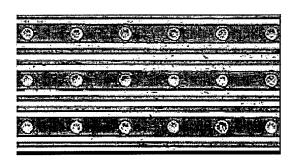


Fig. 14

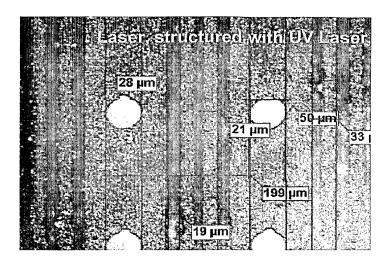


Fig. 15

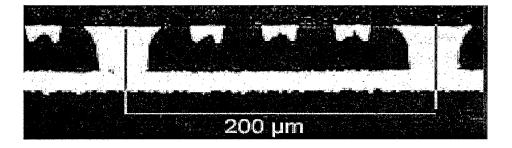


Fig. 16

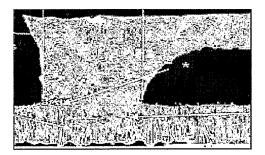


Fig. 17

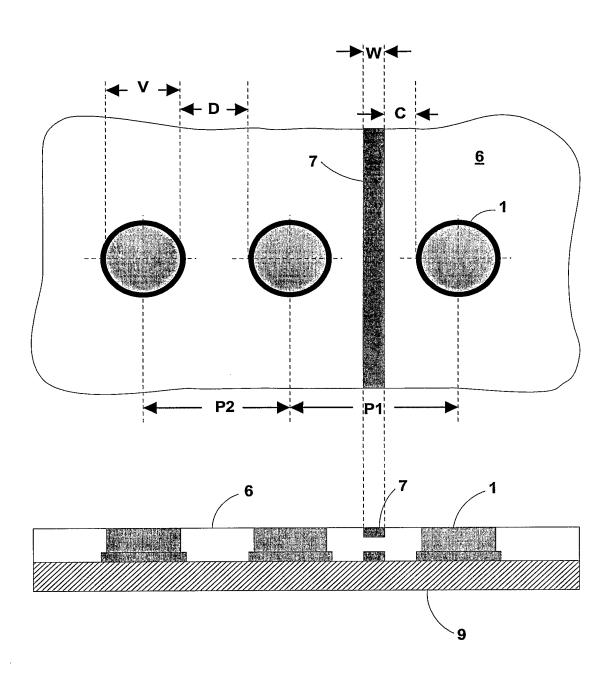


Fig. 18